

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Fumitake Kaneko et al.

Application No.: 10/587,438

Confirmation No.: 5387

Filed: July 26, 2006

Art Unit: 1709

For: **NEGATIVE RESIST COMPOSITION AND
METHOD FOR FORMING RESIST
PATTERN**

Examiner: Not Yet Assigned

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated June 21, 2007, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.